Notice of Allowability	Application No.	Applicant(s)	- 13
	10/718,887	XU ET AL.	
	Examiner	Art Unit	
	Quoc D. Hoang	2818	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.			
1. This communication is responsive to 9/22/2005.			
2. X The allowed claim(s) is/are 39,47 and 48.			
<ol> <li>Acknowledgment is made of a claim for foreign priority ur</li> <li>a) All b) Some* c) None of the:</li> <li>1. Certified copies of the priority documents have</li> <li>2. Certified copies of the priority documents have</li> <li>3. Copies of the certified copies of the priority documents have</li> <li>International Bureau (PCT Rule 17.2(a)).</li> </ol>	e been received. e been received in Application No.		tion from the
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.  THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.			
4. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.			
5. CORRECTED DRAWINGS ( as "replacement sheets") must be submitted.			
(a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review ( PTO-948) attached			
1) 🔲 hereto or 2) 🔲 to Paper No./Mail Date			
<ul><li>(b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date</li></ul>			
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t	.84(c)) should be written on the dra he header according to 37 CFR 1.12	wings in the front (not the 21(d).	back) of
6. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.			
Attachment(s)			
1. Notice of References Cited (PTO-892)		al Patent Application (PT	O-152)
2.  Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summa Paper No./Mail I		
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0			
Paper No./Mail Date 10/24/05  4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	<u>_</u>	ement of Reasons for Allo	owance
	9.		
David Nelms Supervisory Patent Examiner Technology Center 2800			

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### **DETAILED ACTION**

## Response to Amendment

1. Amendment filed on 09/22/2005 has been entered and made of record as Paper No. 0905. In Amendment, claims 28-38, 40-46, and 49 have been cancelled. Claims 39, 47 and 48 are pending in the application.

Applicants' remarks have been considered.

#### Examiner's Amendment

2. An examiner's amendment to the record appears below. Should any changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mr. Hrna on November 17, 2005.

- In claim 39, line 3, changing "a nitrogen free silicon carbide cap" into --a first nitrogen free silicon carbide cap--.
- In claim 39, line 6, changing "etch dielectric layers" into -- etch stop dielectric layers --.
- In claim 39, line 10, changing "nitrogen free silicon carbide cap" into --a second nitrogen free silicon carbide cap--.

# Allowable Subject Matter

3. Claims 39, 47 and 48 are allowed.

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The following is an examiner's statement of reasons for allowance: None of the cited references or combinations thereof disclose or suggest a nitrogen free silicon carbide cap adjacent the nitrogen doped silicon carbide layer as required by the presently claimed invention.

4. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

#### Conclusion

5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Quoc Hoang whose telephone number is (571) 272-1780. The examiner can normally be reached on Monday-Friday from 8.00 AM to 5.00 PM.

If attempt to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571) 272-1787. The fax phone numbers of the organization where this application or proceeding is assigned are (703) 872-9306 for regular communications and (703) 872-9306 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

Quoc Hoang

Patent examiner/AU 2818

David Nelms
Supervisory Patent Examiner
Technology Center 2800